

Image



520.39440X00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): S. UTO, et al
Serial No.: 09/764,457
Filed: January 19, 2001
For: ULTRAVIOLET LASER-GENERATING DEVICE AND DEFECT
INSPECTION APPARATUS AND METHOD THEREFOR
Group: 2881
Examiner: P. Johnston

STATEMENT OF SUBSTANCE OF INTERVIEW


Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

February 20, 2004

Sir:

Applicants note that an Interview Summary accompanied the Notice of Allowance and confirm that the undersigned attorney conducted a telephone interview with the Examiner, Phillip Johnston, on January 15, 2004, during which time amendments to the claims as effected by the Examiner's Amendment accompanying the Notice of Allowance and Interview Summary, were discussed and authorized in order to place the application in condition for allowance. Thus, applicants confirm the substance of the interview as provided by the Interview Summary and although applicants consider the submission of this paper to be unnecessary, to avoid any question concerning the requirements for applicant to file a statement of the substance of the interview, this statement is submitted.

Respectfully submitted,



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